SHEET 1 OF 1

INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449) U.S. PATENT				ATTY. DOCKET NO. 62807-033		SERIAL NO. 10/062,562		
				APPLICANT Yuichi SATSU et al.				
				FILING DATE February 5, 2	002	GROUP 1755		
U.S. PATENT DOCUMENTS								
EXAMINER'S INITIALS	PATENT NO.	DATE		NAME \	CLASS	SUBCLASS		ING DATE
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INITIALS	PATENT NO.	PATENT NO. DATE		COUNTRY		SUBCLASS	Yes	No
MF	6-172618	06/21/1994	Japan (w/ F	English Abstract)				
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				r, Title, Date, Per				
Mf	"Integrated Capacitors Using Polymer-Ceramic Composites for MCM-L", Premjeet CHAHAL et al., ISHM '96 PROCEEDINGS, pp. 126-131							
me	"Effective Dielectric Constant Prediction of Polymer-ceramic Composite Based on Self- consistent Theory", Yang RAO et al., 2000 Electronic Components and Technology Conference, pp. 615-618							
ms	"SiO ₂ Film by ECR-CVD for Thin-Film Capacitors Directly Fabricated on Epoxy/Glass Printed Wiring Boards", Teruhito MATSUI et al., Circuit Technology, Vol. 9, No. 7, pp. 497-502							
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EXAMINER	10/		DATE CONSIDERED					
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.